

Title	表紙
Sub Title	
Author	
Publisher	慶應義塾大学理工学部
Publication year	1987
Jtitle	Keio Science and Technology Reports Vol.40, No.2 (1987. 12)
JaLC DOI	
Abstract	
Notes	表紙裏：編集委員会
Genre	
URL	https://koara.lib.keio.ac.jp/xoonips/modules/xoonips/detail.php?koara_id=KO50001004-00400002--001

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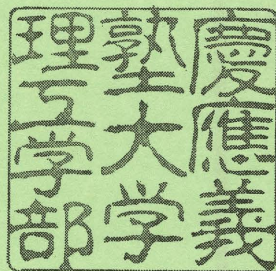
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KEIO SCIENCE AND TECHNOLOGY REPORTS
VOL. 40 NO. 2 (1987)

THEMAL GENERATION OF FRENKEL
PAIR IN SILICON

By

MASAYUKI YOSHIDA AND SATORU MATSUMOTO



FACULTY OF SCIENCE AND TECHNOLOGY
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KEIO SCIENCE AND TECHNOLOGY REPORTS Vol. 40, No. 2, Dec. 1987

Published by the Faculty of Science and Technology, Keio University

Kohoku-ku, Yokohama-shi, Kanagawa 223, Japan

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